



(CFW)

**IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE**

Applicant: Shin Seung Park

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Serial No.: 10/735,228

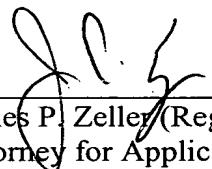
Filed: December 12, 2003

Title: METHOD OF FORMING  
METAL LINE OF  
SEMICONDUCTOR  
DEVICE

Group Art Unit: 1765

Examiner: To be assigned

Attorney Docket No.: 29936/39847

  
\_\_\_\_\_  
James P. Zeller (Reg. No. 28,491)  
Attorney for Applicants

**AMENDMENT "A"**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please amend this application as follows:

the amendments to the claims section begins on page 2 of this paper;

the remarks section begins on page 4 of this paper.